

Title (en)
APPARATUS FOR GENERATING F SB 2 /sb GAS AND METHOD FOR GENERATING F SB 2 /SB GAS, AND F SB 2 /SB GAS

Title (de)
VORRICHTUNG ZUR ERZEUGUNG VON F2-GAS UND VERFAHREN ZUR ERZEUGUNG VON F2-GAS SOWIE F2-GAS

Title (fr)
APPAREIL ET PROCEDE DE PRODUCTION D'UN GAZ F SB 2 /SB ET GAZ F SB 2 /SB AINSI OBTENU

Publication
EP 1457586 A1 20040915 (EN)

Application
EP 02783802 A 20021209

Priority
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Abstract (en)
An F2 gas generating apparatus for generating a high purity F2 gas by subjecting an electrolytic bath made of KF.2HF to electrolysis is characterized by comprising a preparing system for preparing KF.2HF from KF or KF.HF, an HF supplying system for supplying HF into the electrolytic bath and the preparing system, and an F2 gas generating system for generating the F2 gas by subjecting KF.2HF prepared by the preparing system to electrolysis. <IMAGE>

IPC 1-7
C25B 1/24; **C25B 15/02**

IPC 8 full level
C25B 1/24 (2006.01); **C25B 15/00** (2006.01)

CPC (source: EP KR US)
C25B 1/245 (2013.01 - EP KR US); **C25B 15/00** (2013.01 - EP US); **C25B 15/021** (2021.01 - KR); **C25B 15/085** (2021.01 - KR)

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